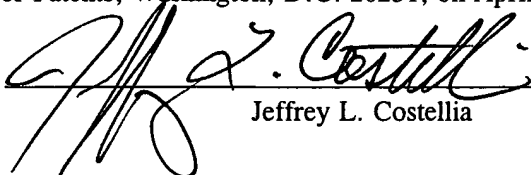


- 1 -

Docket: 0756-1614

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on April 21, 1999.

  
Jeffrey L. Costellia

**RECEIVED**

APR 29 1999

**GROUP 1700**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT application of )  
Takeshi FUKUNAGA et al. )  
Serial No. 08/781,920 ) Art Unit: 1762  
Filed: December 30, 1996 ) Examiner: M. Padgett  
For: METHOD OF FABRICATING A )  
SEMICONDUCTOR DEVICE )  
UTILIZING A CATALYST )  
MATERIAL SOLUTION ) Date: April 21, 1999

**AMENDMENT**

Honorable Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action mailed December 21, 1998, please  
amend the subject application as follows.

04/27/1999 NHASSANI 00000072 08781920

01 FC:103  
02 FC:115

90.00 OP  
110.00 OP